

03500.017320.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
TAKESHI ICHIKAWA ET AL. ) : Examiner: Christopher M. Raabe  
Application No.: 10/516,545 ) : Group Art Unit: 2879  
Filed: December 2, 2004 ) :  
For: ELECTRON-EMITTING DEVICE )  
AND MANUFACTURING :  
METHOD THEREOF ) February 16, 2007

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SUBMISSION OF ENGLISH TRANSLATION  
OF NOTIFICATION OF THE FIRST OFFICE ACTION

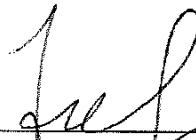
Sir:

The Examiner's attention is directed to the attached English translation of a Notification of the First Office Action issued by a foreign patent office in a foreign counterpart of the present application. The references cited in the Notification were cited in a previous Information Disclosure Statement in the present application. Accordingly, no copies of the cited documents are submitted herewith.

Entry hereof is respectfully requested.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



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